DEPARTMENT OF __METALLURGICAL AND MATERIALS ENGINNERING__

NATIONAL INSTITUTE OF TECHNOLOGY, TIRUCHIRAPPALLI

COURSE PLAN – PART I				
Name of the programme and specialization	M Tech. (Materials Science and Engineering)			
Course Title	Electrical, Magnetic and Optical Materials			
Course Code	MT 651	No. of Credits	3	
Course Code of Pre- requisite subject(s)	Nil			
Session	July 2022	Section (if, applicable)	NA	
Name of Faculty	Dr. N. Ramesh Babu	Department	MME	
Email	rameshrohith@gmail. com nrb@nitt.edu	Telephone No.	2503464 99444932221	
Name of Course Coordinator(s) (if, applicable)	NA			
E-mail	NA	Telephone No.	NA	
Course Type	Core Course			

Syllabus (approved in BoS)

Electrical and Dielectric Materials: Review of electrical conduction - resistivity and dielectric phenomena - concept of polarization - effects of composition, frequency and temperature on these properties - discussion on specific materials used as conductors (OFHC Copper, Al alloys, Fe-Si alloys, amorphous metals) - discussion on specific materials used as dielectrics (ceramics and polymers) - dielectric loss, dielectric breakdown - ferro electricitypiezo and pyro electricity.

Magnetic Materials: Introduction to dia, para, ferri and ferro magnetism - hard and soft magnetic materials - iron- silicon alloys – iron, nickel alloys - ferrites and garnets - (Ag - Mn - Al) alloys - (Cu - Ni-Co) alloy - fine particle magnets - applications of hard and soft magnetic materials - Giant magneto resistance- Nanomaterials.

Semiconducting and Superconducting Materials: Review of semiconducting materials - concept of doping - simple and compound semiconductors - amorphous silicon, oxide semiconductors; amorphous semiconductors - FER, MOSFET and CMOS - Concept of super condcutivity

Production of Electronic Materials: Review of electronic materials - methods of crystal growth for bulk single crystals - zone melting-refining, leveling - synthesis of epitaxial films by VPE, PVD, MBE and MOCVD techniques - lithography; production of silicon - starting applications.

Optical Properties of Materials:Introduction toelectromagnetic radiation, atomic and electronic interactions with electromagnetic radiation, optical propert ies of metals, optical propert ies of

nonmetals, opacity and translucency in insulators, color of materials, applications of optical phenomena-luminescence, photoconductivity, lasers, optical fibers in communications

COURSE OBJECTIVES

The objective of this course is to provide students a fundamental understanding of electrical, magnetic and optical properties of materials and to apply those fundamentals for selecting and developing materials for different engineering applications.

COURSE OUTCOMES (CO)			
	Programme Outcomes (PO)		
Course Outcomes	(Enter Numbers only)		
After the completion of this course, the student will			
be able to:			
1.Understand the conducting, semiconducting, superconducting, dielectric, ferro-eleletric and piezoelectric behavior of materials	(1,2,3)		
2. Differentiate between diamagnetic, paramagnetic, ferromagnetic, ferromagnetic, and anti-ferromagnetic behavior of materials	(1,2,3,4,5)		
3. Synthesis and processing of semi-conducting materials for engineering applications	(1,4,6)		
4. Study the effect of composition, structure and temperature on the properties of the materials .	(1,6,7)		
5. Describe the interactions of light with materials and its effects at the interface	(1,2,3)		
6. Understand the working principles of solid state devices, etc.	(1,5,7)		

COURSE PLAN – PART II

COURSE TEACHING AND LEARNING ACTIVITIES			
S.No.	Week/Contact Hours	Торіс	Mode of Delivery
1.	1-111	Electrical and Dieelectric Materials	PPT, Black board
2.	IV-VI	Semiconducting Materials and Supercondcuting Materials	FFT, DIACK DUALU
3.	VII-IX	Magentic Materials	
4.	X-XII	Production of electronic Materials	
5.	XIII-XIV	Optical Properties of Materials	

S.No.	Mode of Assessment	Week/Date	Duration	% Weightage
1	CT-1	Sep 2022	1 hour	25
2	CT-2	Oct 2022	1 hour	25
3	Seminar and Review writing	Nov 2022	-	20
	Compensation Assessment* Re-test	Nov 2022	1 hour	25 (If any student misses Mid test for medical reasons)
	Attendance			Nil Minimum 75% attendance require for writing the semester examination as per institute norms
4	Final Assessment * End semester exam	As per Institute schedule	2 h	30

• Attendance mandatory; refer to guidelines on page 5

COURSE EXIT SURVEY (mention the ways in which the feedback about the course shall be assessed)

The feedback from students will be assessed based on the questionnaire prepared by the institute and expected minimum attainment to be 75%.

COURSE POLICY (preferred mode of correspondence with students, compensation assessment policy to be specified)

The students are expected to attend all the classes except for medical reasons. Minimum

attendance of 75% is required for writing the semester examination.

Apart from technical content and presentation, plagiarism will be checked for the written assignments

MODE OF CORRESPONDENCE (email/ phone etc)

The Course Coordinator is available for consultation at any time.

The phone number and email id will be given to the students at the beginning of the course

COMPENSATION ASSESSMENT POLICY

Retest will be conducted for the portion of the course completed.

ATTENDANCE POLICY (A uniform attendance policy as specified below shall be followed)

- > At least 75% attendance in each course is mandatory.
- > A maximum of 10% shall be allowed under On Duty (OD) category.
- Students with less than 65% of attendance shall be prevented from writing the final assessment and shall be awarded 'V' grade.

ACADEMIC DISHONESTY & PLAGIARISM

- Possessing a mobile phone, carrying bits of paper, talking to other students, copying from others during an assessment will be treated as punishable dishonesty.
- Zero mark to be awarded for the offenders. For copying from another student, both students get the same penalty of zero mark.
- The departmental disciplinary committee including the course faculty member, PAC chairperson and the HoD, as members shall verify the facts of the malpractice and award the punishment if the student is found guilty. The report shall be submitted to the Academic office.

The above policy against academic dishonesty shall be applicable for all the programmes.

ADDITIONAL INFORMATION

The Course Coordinator is available for consultation at any time.

Students can also contact me at any time through phone or by e-mail. Relative grading as per the Institute Policy

FOR APPROVAL

N Ramesh Cake

Course Faculty

S. Muth

B. HOD -1.

CC-Chairperson

Guidelines:

- a) The number of assessments for a course shall range from 4 to 6.
- b) Every course shall have a final assessment on the entire syllabus with at least 30% weightage.
- c) One compensation assessment for absentees in assessments (other than final assessment) is mandatory. Only genuine cases of absence shall be considered.
- d) The passing minimum shall be as per the regulations.

B.Tech. Admitted in				P.G.
2018	2017	2016	2015	
		Peak/3 or cl whichever is low	•	40%

- e) Attendance policy and the policy on academic dishonesty & plagiarism by students are uniform for all the courses.
- f) Absolute grading policy shall be incorporated if the number of students per course is less than 10.
- g) Necessary care shall be taken to ensure that the course plan is reasonable and is objective.